	Application No.	Applicant(s)
Notice of Allowability	10/517,655	SATO ET AL.
	Examiner	Art Unit
	Bryan Bui	2863
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308. 1. This communication is responsive to 11/16/06.		
2. X The allowed claim(s) is/are 35-38,47-131,135,139,143-145,147-149,151-153,155-157,159-161 and 163-165.		
3. Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some* c) None of the: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 4. A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient. 5. CORRECTED DRAWINGS (as "replacement sheets") must be submitted. (a) including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached 1) hereto or 2) to Paper No./Mail Date		
(b) including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).		
6. DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.		
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Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☐ Information Disclosure Statements (PTO/SB/08), Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	 5. ☐ Notice of Informal F 6. ☐ Interview Summary Paper No./Mail Da 7. ☐ Examiner's Amenda 8. ☒ Examiner's Stateme 9. ☐ Other 	(PTO-413), te
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- 1. Applicants' paper filed on 11/16/2006 have been received and entered. Claims 1-34, 39-46, 132-134, 136-138, 140-142, 146, 150, 154, 158, 162 and 166 have been cancelled. Claims 35, 48-50, 79, 98, 131, 144-145, and 148-149 have been amended. Claims 35-38, 47-131, 135, 139, 143-145, 147-149, 151-153, 155-157, 159-161, and 163-165 are pending in the application,
- 2. Applicants' remarks have been considered.

Allowable Subject Matter

3. The following is an examiner's statement of reasons for allowance:

Claims 35-38, 47-131, 135, 139, 143-145, 147-149, 151-153, 155-157, 159-161, and 163-165 are allowable over the prior art of record because none of the prior art whether taken singularly or in combination to teach the claimed combination as recited, especially when these limitations are considered within the specific combination with other limitations of the claim. The prior art fails to teach the displacement data of the plane of the semiconductor wafer are displacement of a plane in a direction of thickness in the front surface or the back surface of the wafer when the semiconductor wafer is placed without suction; the thickness data of the semiconductor wafer are displacement of a plane in a direction of thickness in one main surface of the wafer when an entire of another main surface of the semiconductor wafer is sucked; the displacement data of the plane of the semiconductor wafer are displacement of planes in a direction of thickness in the front surface and the back surface of the wafer when a part of the semiconductor wafer is sucked with a wafer holder, and the thickness data of the semiconductor wafer are difference of the displacement data of planes in the front

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surface and the back surface of the wafer when a part of the semiconductor wafer is sucked (claims 35 and 131).

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

4. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Bryan Bui whose telephone number is 571-272-2271.

The examiner can normally be reached on M-Th from 7am-4pm, and Alternate Fridays.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, John E. Barlow can be reached on 571-272-2269. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

BRYAN BUI PRIMARY EXAMINER

BB

12/28/2006